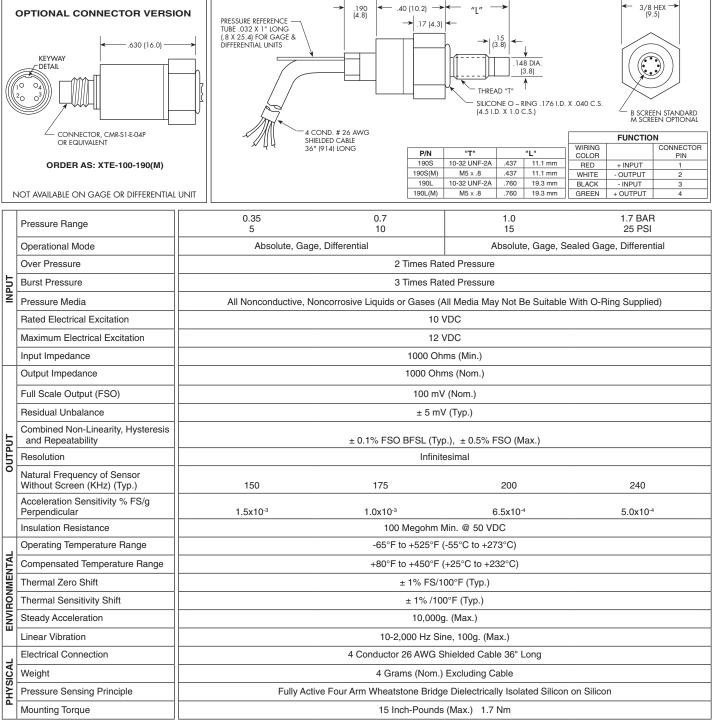
WINIATURE RUGGEDIZED HIGH TEMPERATURE PRESSURE TRANSDUCER XTE-190 (M) SERIES

- Wide Temperature Capability -65°F To 525°F
- Easy Installation
- Silicon on Silicon Integrated Sensor VIS[®]
- High Natural Frequency

The ruggedness of this sensor has not compromised its performance. It was designed for ease of installation and will operate in temperatures up to $525^{\circ}F$ ($273^{\circ}C$). Its wide operating range (- $65^{\circ}F$ to + $525^{\circ}F$) makes it ideal for numerous applications in Aerospace and other areas of industry.





Note: Custom pressure ranges, accuracies and mechanical configurations available. Dimensions are in inches. Dimensions in parenthesis are in millimeters. All dimensions nominal. (I) Continuous development and refinement of our products may result in specification changes without notice. Copyright © 2014 Kulite Semiconductor Products, Inc. All Rights Reserved. Kulite miniature pressure transducers are intended for use in test and research and development programs and are not necessarily designed to be used in production applications. For products designed to be used in production programs, please consult the factory.